

Transaction Information

Tool ID	CMP Retaining Rings
Tool Status	Disconnected
Location	Malta, USA
Wafer Size	300 mm
Fab Section	CMP
Tool Available Date	2022-07-19

General Product Information

Vendor Supplier	Applied Materials
Model	0040-62020
Vintage	2019
Serial No	N/A
Asset Description	RETAINING RING, FLANGED PPS AEP, 300MM PROFILER
Software Version	N/A
CIM	N/A
Process	CMP

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	RETAINING RING, FLANGED PPS AEP, 300MM PROFILER	11	OK
Handler System	N/A		
Factory Interface	NONE		
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status

Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	

Tool Pictures

General

Retaining Ring Pictures







Additional Configuration Files